

 <p>LIST OF REFERENCES CITED BY APPLICANT (Use additional sheets if necessary)</p>				ATTY. DOCKET NO.		APPLICATION NO.	
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				APPLICANT			
				Chen et al.			
FILING DATE				GROUP			
February 22, 2002				1762			
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
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	AC						
	AD						
	AE						
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							YES NO
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7	AK	Boonekamp et al., Adsorption of Nanometer-Sized Palladium Particles on Si(100) Surfaces, 10 Langmuir 4089-4094 (American Chemical Society, 1994).					
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7	AM	Hidber et al., New Strategy for Controlling the Size and Shape of Metallic Features Formed by Electroless Deposition of Copper: Microcontact Printing of Catalysts on Oriented Polymers, Followed by Thermal Shrinkage, 12 Langmuir 5209-5215 (American Chemical Society, 1996).					
EXAMINER <i>Michael Barr</i>				DATE CONSIDERED <i>12/29/03</i>			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							